

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the application of:

Toshikazu ISHIKAWA et al.

Appln. No.:

Filed: HEREWITH

For: SEMICONDUCTOR DEVICE

* * *

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

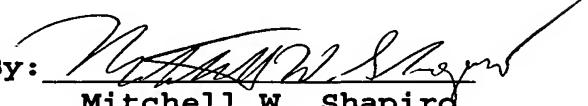
Pursuant to 37 C.F.R. § 1.56, and without any assertion as to materiality or prior art effect, the document listed on the attached Form PTO-1449 is hereby cited.

The document on the attached List was cited in the specification, on page 2, and its relevance is indicated therein.

Respectfully submitted,

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November 3, 2003

FORM PTO-1449			Atty. Docket No. XA-9960	Appln. No.			
LIST OF DOCUMENTS CITED BY APPLICANT			Applicant Toshikazu ISHIKAWA et al.				
			Filing Date HEREWITH	Group			
U.S. PATENT DOCUMENTS							
Examiner Initial		Document Number	Date	Name	Class	Sub-class	Filing Date
	AA						
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	AG						
	AH						
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FOREIGN PATENT DOCUMENTS							
Examiner Initial		Document Number	Date	Country	Class	Sub-class	Translation
	AJ	WO 02/103793	12/27/02	PCT			Abstract
	AK						
	AL						
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	AN						
	AO						
OTHER (including author, title, date, pertinent pages, etc.)							
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EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.							